

Application/Control No.	Applicant(s)/Patent under Reexamination
09/866,656	PARK ET AL.
Examiner	Art Unit
Mike Oi	2871

SEARCHED					
Class	Subclass	Date	Examiner		
349	149,151 152	4/12/2005	ZQQ		
345	98,90 80	4/12/2005	ZQQ		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
349	149	4/12/05	200		
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DATE	EXMR
4/12/2005	ZQQ
4/18/05	20U
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